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JUN 06 2003  
TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 09/386,745

Group Art Unit: 1765

Inventors: Cangshan et al

Filed: 8/31/99

Title: Windowless Belt And Method For  
Improving In-Situ Wafer Monitoring

Examiner: V. Perez Ramos

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

In accordance with 37 CFR 1.51, 1.56 and 1.97 to 1.99, the list of references cited on the attached Form PTO-1449 is made of record to assist the Patent and Trademark Office in its examination of this application. A copy of each of the references cited is enclosed herewith. Since we have not received an Office Action on the merits, no fee is believed to be due.

This disclosure statement should neither be construed as a representation that a search has been made, nor as an admission that the information cited is, or is considered to be, material to patentability as defined in 1.56(b).

Respectfully submitted,

A handwritten signature in cursive script, appearing to read "I. Schwartz".

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Date: June 3, 2003